Imprinted photonic crystal nanocavity composed of inversely tapered air holes for highly sensitive optical sensor

Kenichi Maeno¹, Shoma Aki¹, Kazuo Satoh², Shunichi Murakami², Yusuke Sando², Yusuke Kanaoka², Kenji Sueyoshi¹, Hideaki Hisamoto¹, Tatsuro Endo^{1, 3*}

¹ Osaka Prefecture University, Sakai, Osaka 599-8531, Japan.,

² Osaka Research Institute of Industrial Science and Technology(ORIST), Osaka 594-1157, Japan

³ JST PRESTO, Tokyo, Japan

*endo@chem.osakafu-u.ac.jp

Abstract

Polymer-based photonic crystal nanocavity (PCN) composed of tapered and inversely tapered air holes for optical sensing application was successfully fabricated. Polymer-based PCN fabricated by using nanoimprint lithography (NIL) is a promising device for highly-sensitive optical sensor. From the view point of sensing application, the efficiency of light confinement in PCN is a significant factor. However, polymer-based PCN possessed low efficiency caused of low refractive index of polymer material. In this research we found that the shape of air holes composing PCN contributed to the confinement efficiency. We fabricated PCNs composed of cylindrical, tapered, and inversely-tapered air holes by using NIL technique. As an optical measurement result, the inversely tapered one showed the strongest light confinement and two times higher Q value than that of tapered one.

Key words: Photonic crystal nanocavity, Optical sensor, Nanoimprint lithography, inverse taper

Introduction

Photonic crystal nanocavity (PCN) is an optical resonator capable to confine the light of specific wavelength strongly into nanoscale based on Bragg diffraction derived from wavelengthdimensional periodic nanohole array. This optical phenomenon induces strong light-matter interaction within nanoscale and has applied to various applications, such as ultra-small light sources [1], optical manipulation systems [2], and also optical biosensors [3]. For these applications, quality (Q) factor which designates the efficiency of light confinement is a significant parameter. The value of Q factor is defined as $Q = \lambda_0/\Delta\lambda$. Here λ_0 and $\Delta\lambda$ indicate resonant wavelength and full width of half maximum of resonant spectrum, respectively. We previously reported polymer-based PCN fabricated on metal substrate which can prevent the light leakage to the base substrate, and successfully observed visible light confinement into PCN [4]. However, the Q value was very low, below one hundred, because of the light leakage to air from photonic crystal slab caused by low refractive index of polymer material. Therefore, suppression of this leakage is important point to improve Q value.

Here, we focused on the fact that the smaller air hole radius leads the higher average refractive index ($n_{\text{ave.}}$) of the slab because of the high occupancy of polymer material. This fact means the $n_{\text{ave.}}$ value is "locally" controllable by tuning air hole radius along the depth direction (Fig. 1). In this study, we fabricated three types of polymer-based PCNs composed of different shape of air holes, cylindrical, tapered and inversely tapered shapes. Q values were evaluated by spectrometric analysis.

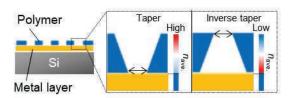


Fig. 1. Schematic illustration of $n_{\text{ave.}}$ controlled by tuning air hole radius along the depth direction.

Experimental

Ideal Q values ($Q_{\rm ideal}$) of polymer-based PCNs composed of triangle lattice cylindrical, tapered, or inversely tapered air holes were calculated by using simulation analysis (FDTD solutions). The lattice constant was 300 nm, and the air hole radius was 80 nm. In the case of tapered

or inversely tapered shape, the maximum and the minimum air hole radii were 90 nm and 70 nm, respectively.

These structures were fabricated according to the procedure described below (Fig. 2). Firstly, the pillar structure of cylindrical, tapered, or inversely tapered shape was fabricated on Si by using electron beam lithography and dry etching process (Fig. 1 (a)). Secondly, the structure was transferred to UV resin (NOA 81) as a 2nd mold by using UV-NIL (Fig. 2 (b)). Thirdly, water-soluble polymer (PVA: poly(vinyl alcohol)) was coated on 2nd mold and dried up under 80 ° C. Then, a sacrificial mold was obtained by demolding (Fig. 2 (c)). Finally, the polymer resin (SU-8 2000.5) was coated on the sacrificial mold and attached on metal substrate. After dissolving of sacrificial mold, polymerbased PCN composed of cylindrical or tapered air holes was fabricated (Fig. 2 (d) upper). Only the case of inversely tapered shape, the tapered structure of SU-8 resin was attached on silicone rubber (PDMS: poly (dimethyl siloxane)). After dissolving of sacrificial mold and flipping PDMS, the structure of SU-8 resin was transferred on metal substrate, and the PCN composed of inversely tapered air holes was fabricated (Fig. 2 (d) lower).

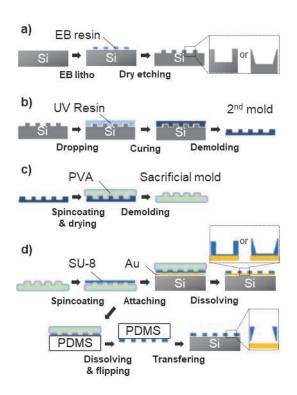


Fig. 2. Fabrication procedure of polymer-based PCN.

Experimental Q values (Q_{exp}) of fabricated PCNs were evaluated as described below. A broadband white light (400-800 nm) was

irradiated from the edge of photonic crystal structure. Then, the light of resonant wavelength was confined in PCN. The confined light was measured by using spectrometer, and Q_{exp} was calculated by λ_{o} and $\Delta\lambda$ of measured spectrum.

Results and discussion

Measured spectrum of PCN composed of inversely tapered air holes was shown in Fig. 3. In Fig. 3, very sharp peak was observed at wavelength of 580 nm ($\Delta\lambda$ = 3 nm).

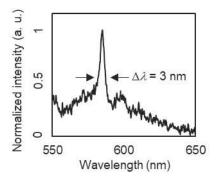


Fig. 3. Measured spectrum of PCN composed of inversely tapered air holes.

Evaluated Q_{ideal} and Q_{exp} of PCNs were summarized in Table 1. The PCN composed of inversely tapered air holes showed the highest Q value, approximately two times higher than that of tapered one. These results suggested that the shape of air hole was a significant factor for improvement of Q values.

Table 1: Qideal and Qexp of each PCNs.

	Taper	Cylinder	Inverse
			taper
			/ \
Q _{idel}	159	202	232
Q _{exp}	95	150	203

Acknowledgement

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